

**Notice of References Cited**

Application/Control No.

10/791,410

Applicant(s)/Patent Under  
Reexamination  
SUN ET AL.

Examiner

Timothy J. Henn

Art Unit

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0223008	12-2003	Kim et al.	348/340
*	B	US-7,423,689	09-2008	Kim et al.	348/374
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	S					
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**NON-PATENT DOCUMENTS**

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